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BIB DATA SHEET

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RULE APPLICANTS Tomohisa Konno, Tokyo, JAPAN; Masayuki Motonari, Tokyo, JAPAN; Masayuki Hattori, Tokyo, JAPAN; Nobuo Kawahashi, Tokyo, JAPAN; ** CONTINUING DATA **********************************	SERIAL NUM	DAT				CLASS	GR	GROUP ART UNIT		ATTORNEY DOCKET NO.		
APPLICANTS Tomohisa Konno, Tokyo, JAPAN; Masayuki Motonari, Tokyo, JAPAN; Masayuki Motonari, Tokyo, JAPAN; Masayuki Hattori, Tokyo, JAPAN; Nobuc Kawahashi, Tokyo, JAPAN; Nobuc Kawahashi, Tokyo, JAPAN; *** CONTINUING DATA *** FOREIGN APPLICATIONS *** *** FOREIGN APPLICATIONS *** *** FOREIGN APPLICATIONS *** *** FOREIGN FILING LICENSE GRANTED ** 05/11/2004 Foreign Priority claimed					451	3723		240882US0				
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Foreign Priority claimed	JAPAN 2002-225906 08/02/2002											
35 USC 119(a-d) conditions met	** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/11/2004											
Verified and // MAURINA T RACHUBA/				☐ Met af	ter	· · · · · · · · · · · · · · · · · · ·						
Acknowledged Examiner's Signature Initials ADDRESS OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES TITLE Aqueous dispersion for chemical mechanical polishing and production process of semiconductor device FILING FEE RECEIVED 1080 FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: All Fees All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other	·		▼	Allowa	ince		UKA			AI 2	CLAIIVIS	
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